Substitute	for Form 1449	9/PTO		Complete if Known			
	INFOR	<b>AMS</b>	TION DISCLOSUR	Application Number	09/895,787		
			•	Filing Date	June 30, 2001		
	SIAII		ENT BY APPLICAN	First Named Inventor:	Emir Gurer		
		(use as	s many sheets as necessary)	Unit Unit	1752		
				Examiner Name	Gilliam, Barbara Lee		
Sheet	1	1 of 2		PADEMAM	Attorney Docket Number	6601P019X3	
			U.S. PATEN	T DOCUMENTS			
Examiner Initials*	Cite No.'	Num	Document Number ber-Kind Code <sup>2</sup> (# known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		US-	2001/0017103 A1	08-30-2001	Takeshita et al.		
		US-	2001/0033895 A1	10-25-2001	Minami et al.		
		US-	2002/0127334 A1	09-12-2002	Gurer et al.		
		US-	2002/0150691 A1	10-17-2002	Kitano et al.		
96		US-	5,670,210	09-23-1997	Mandal et al.		
	<del></del>	us-	6,027,760	02-22-2000	Gurer et al.		
		US	6,191,053 B1	02-20-2001	Chun et al.		
		U3-	6,248,168 B1	06-19-2001	Takeshita et al.		
		US	6,317,642 B1	11-13-2001	You et al.		
		US	6,387,825 B1	05-14-2002	You et al.		
		US-	6,407,009 B1	06-18-2002	You et al.		
<u></u>		US-	6.468.951 B1	10-22-2002	Grieger et al.		
		US-					
		US-		· · · · · · · · · · · · · · · · · · ·	<u></u>	-	

		FO	REIGN PATEN	IT DOCUMENTS		
Examiner Initials*	Cite No.¹	Foreign Patent Document  Country Code <sup>3</sup> Number* Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Т°
367		WO 98/57757	12-23-1998	Massachusetts Institute Of Technology		
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Sheet	2		of 2	,	Attorney Docket Number	6601P019X3	
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Examiner Initials*	Cite No <sup>1</sup>						T <sup>2</sup>
367		DERKSEN, JAMES, ET AL., Extrusion-Spin Coating: An Efficient Photoresist Coating Process for Wafers, 1999 IEEE International Symposium On Semiconductor Manufacturing Conference Proceedings, (ISSM'99) Santa Clara, CA., October 11-13, 1999, IEEE International Symposium On Semiconductor Manufacturing, New York, NY, October 11, 1999, pages 245-248, XP000933095.					
aller		Search	Report fo	or PCT/US 02/0518	7, mailed November 6, 200	2, 5 pages	
		·					

Examiner	Con ha and A di	Date	2/2/20
Signature	Servara L. Gilliam	Considered	3/8/05

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